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December 19, 2001

BOX PATENT APPLICATION Commissioner for Patents Washington, D.C. 20231

Re:

Application of Takashi KOTSUKA, Yoshiji OKADA and Hiroshi SUZUKI

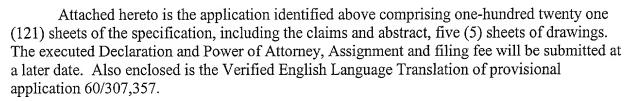
POROUS POLYMER PARTICLE, ALKALI-RESISTANT ANION

EXCHANGER, PRODUCING METHOD THEREOF, COLUMN FOR ION CHROMATOGRAPHY, AND METHOD FOR MEASURING ANIONS

Assignee: SHOWA DENKO K.K.

Our Ref. Q65582





The Government filing fee is calculated as follows:

Total claims	1 -	20	==	X	\$18.00	=	\$.00
Independent claims	1 -	3	_	_ X	\$84.00	=	\$.00
Base Fee							\$740.00

TOTAL FEE \$740.00

Priority is claimed from:

Country	Application No	Filing Date
Japan	P2000-386002	December 19, 2000
Japan	P2001-133064	April 27, 2001
U.S. Provisional	60/307,357	July 25, 2001

The priority documents are enclosed herewith.

Respectfully submitted, SUGHRUE MION, PLLC

Attorneys for Applicant

Bruce E. Kramer

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